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Docket No. 0819-0637

8813

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

The Patent Application of

Yoshihiro MORI et al.

Serial No. 09/942,038

Filed: August 30, 2001

For: CAPACITOR AND METHOD FOR)  
FABRICATING  
SEMICONDUCTOR DEVICE

) Group Art Unit:

) Examiner:

**CERTIFICATE OF MAILING**

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**RESPONSE TO ELECTION REQUIREMENT**

d. 10-15 w/d

Honorable Commissioner for Patents

Washington, D.C. 20231

Sir:

In response to the election requirement in the Office Action of March 26, 2002.  
Applicants hereby elect without traverse the Group II claims - that is, claims 10-15, drawn to  
method for fabricating a semiconductor device.

Examination on the merits is requested.

Respectfully submitted,

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